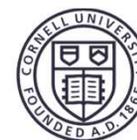


January 14-18 2013

Vacuum Science and Technology for Accelerator Vacuum Systems

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Cornell University, Ithaca, NY*

Duke
UNIVERSITY



Cornell Laboratory
for Accelerator-based Sciences
and Education (CLASSE)



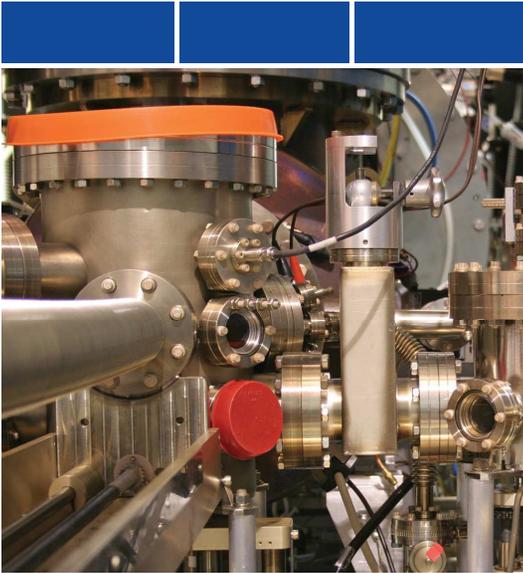


Table of Contents

- Vacuum Fundamentals
- Vacuum Instrumentation
- **Vacuum Pumps**
- Vacuum Components/Hardware
- Vacuum Systems Engineering
- Accelerator Vacuum Considerations, etc.

SESSION 3.2B: Getters

- Getters pump gases by chemically bonding molecules upon impingement
- Two definitions of pumping capacities:
 - Activation capacity
 - Termination capacity
- Based on activation manner, there are two types of getters:
 - Titanium sublimation pumps (TiSPs)
 - Non-evaporable getters (NEGs)
- Both TiSPs and NEGs are widely employed in accelerator vacuum systems

NEGs – The Basics



- Porous alloys with very large active metallic surface area, when activated.
- Bulk Getters - gases diffuse into the interior of the getter material upon heating.
- Gases are categorized into four families based on their interactions with NEGs:
 - ✓ 1. **Hydrogen and its isotopes** - adsorbed reversibly.
 - ✓ 2. **CO, CO₂, O₂, and N₂** - adsorbed irreversibly.
 - ✓ 3. **H₂O, hydrocarbons** - adsorbed in a combination of reversible and irreversible processes. Hydrocarbons are adsorbed very slowly.
 - ✓ 4. **Noble gases** - not adsorbed at all.



Commercial NEGs



- **NEG is available only from:
SAES Getters S.p.A.
Viale Italia , 77
20020 Lainate (Milano) Italy**

**SAES Getters U.S.A., Inc.
1122 E. Cheyenne Mountain Blvd.
Colorado Springs, CO 80906**



NEG Pumping Characteristics (1)



Hydrogen

- *Hydrogen does not form a stable chemical composition with a NEG alloy. It diffuses rapidly into the bulk of the getter and is stored as a solid solution.*
- *Sievert's Law describes the relationship between H_2 concentration within its NEG and its equilibrium pressure.*

$$\text{Log } P = A + 2 \log q - \frac{B}{T}$$

q = H_2 concentration in NEG, Torr - liters/gram

p = H_2 equilibrium pressure, Torr

T = getter temperature, K

A , B constants for different NEG alloys



NEG Pumping Characteristics (2)



CO, CO₂, O₂, N₂, other O-, C-containing molecules

- Active gases are chemisorbed irreversibly by NEG.*
- The chemical bonds of the gas molecules are broken on the surface of the NEG.*
- The various gas atoms are chemisorbed forming oxides, nitrides, and carbides.*
- High temperatures do not break these chemical bonds. High temperatures promote diffusion into the bulk of the NEG.*



NEG Pumping Characteristics (3)



H₂O and Hydrocarbons

- *Water vapor and hydrocarbons are "cracked" on the surface of the NEG.*
- *H₂ is chemisorbed reversibly.*
- *O₂ and C are chemisorbed irreversibly.*
- *However, hydrocarbons sorption efficiency below 500°C is extremely low.*



NEG Pumping Characteristics (4)



Noble gases

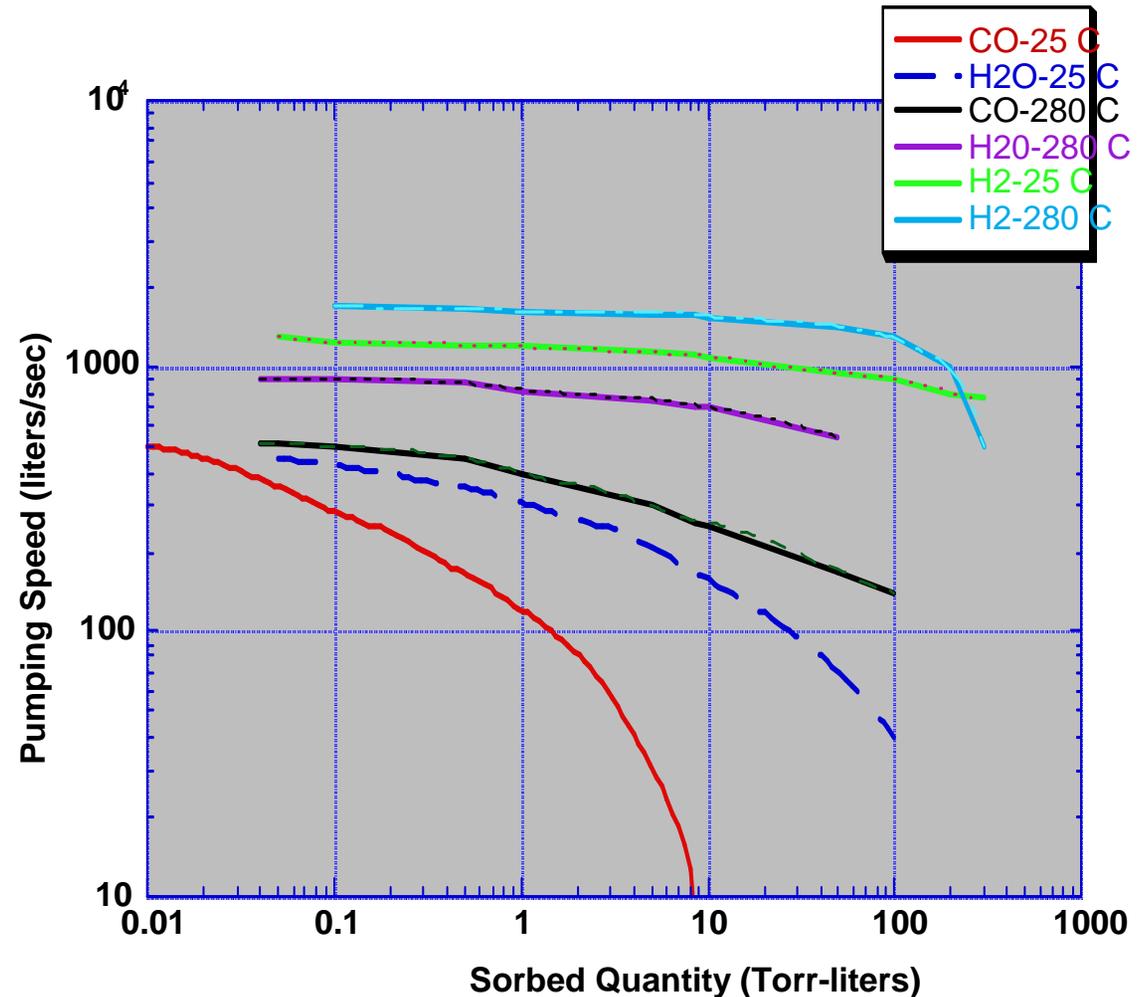
- *NEGs do not sorb Ar, He, Kr, Xe.*
- *Ion pumps are required in combination with NEGs for pumping rare gases.*



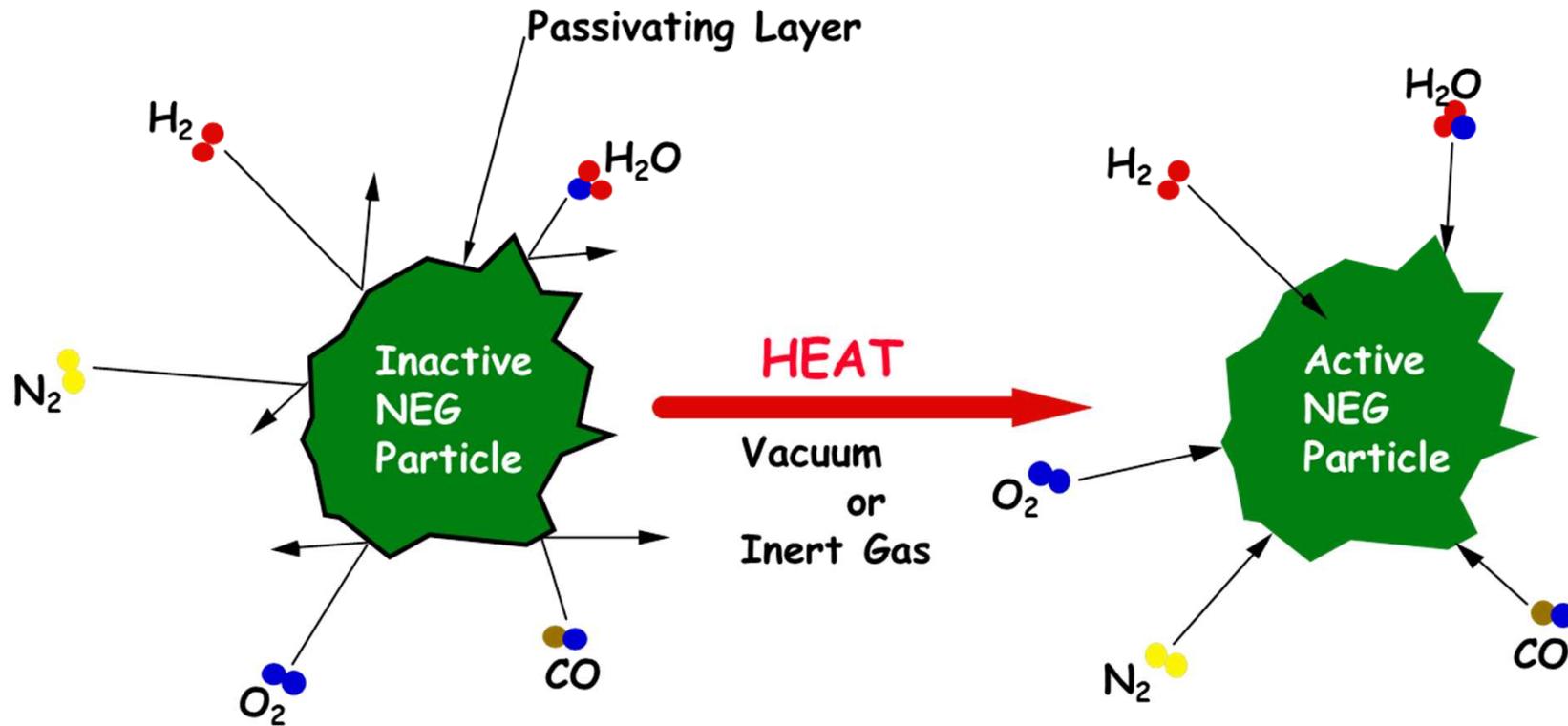
NEG Pumping Characteristics (5)



- *At low throughput, NEG pumping speeds are constant, independent of pressure.*
- *Pumping speeds do, however, vary with NEG temperature.*



Activation Process for NEG



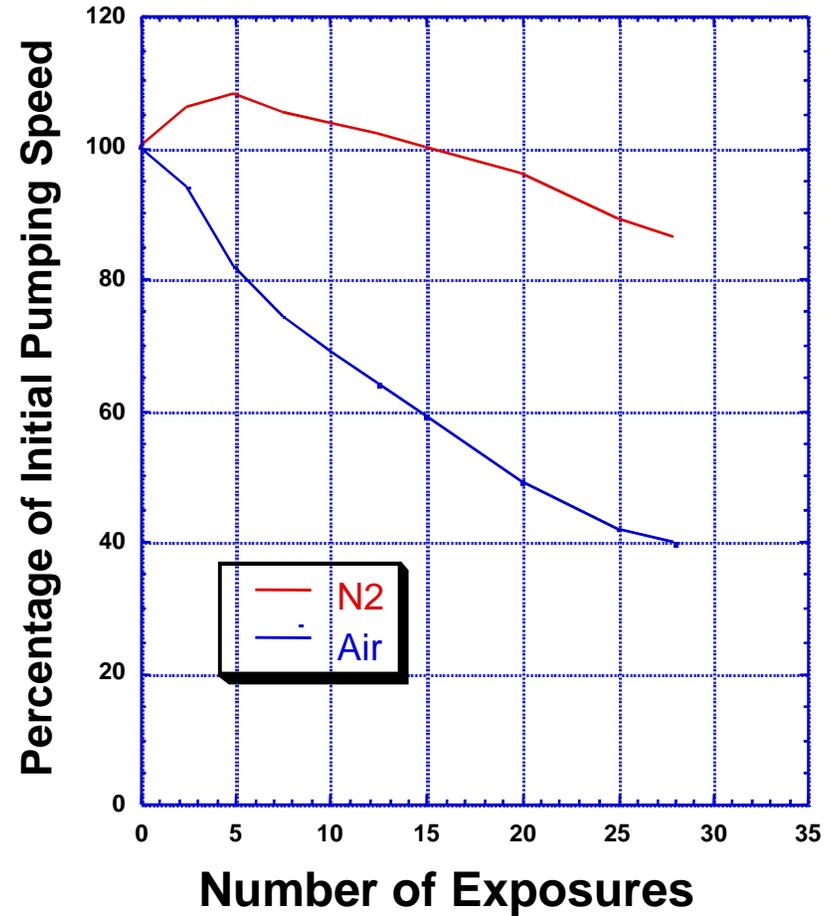
Ref. SAES Getters



Application Notes for NEGs



- ❖ *NEG performance deteriorates due to successive exposures to air (oxygen and water) or N₂.*
- ❖ *Further improvement can be obtained if Argon is used as a protective gas, during long term storage .*
- ❖ *NEG pumps should never be exposed to air while at temperatures higher than 50°C.*
- ❖ *Degassing of NEG's during initial pump-down.*



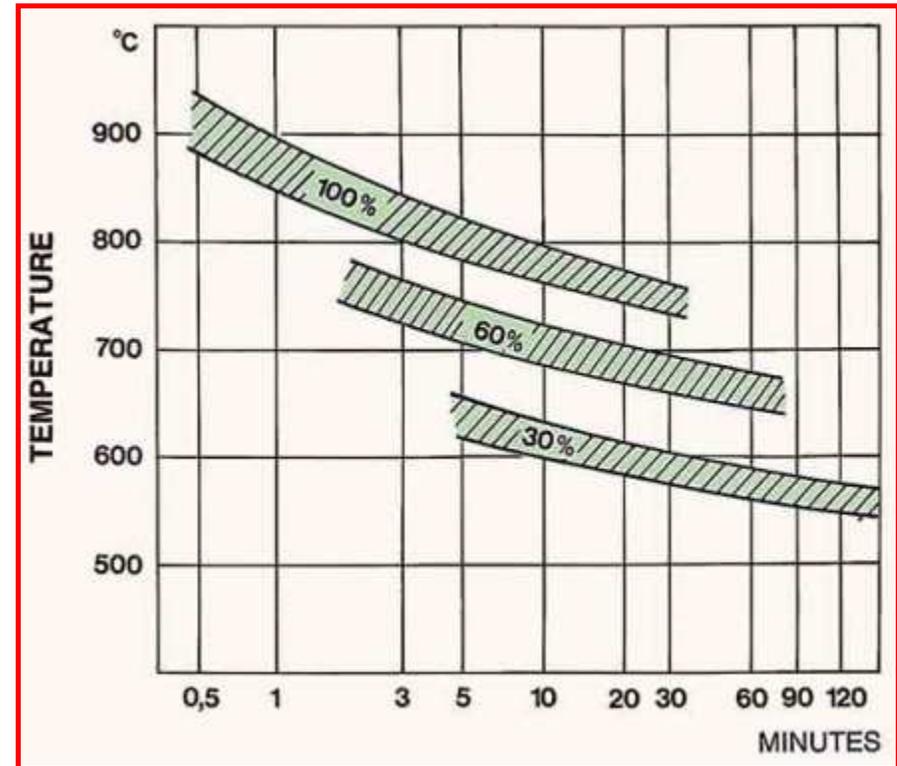
Ref. SAES Getters



SAES ST101[®] Non-evaporable Getters



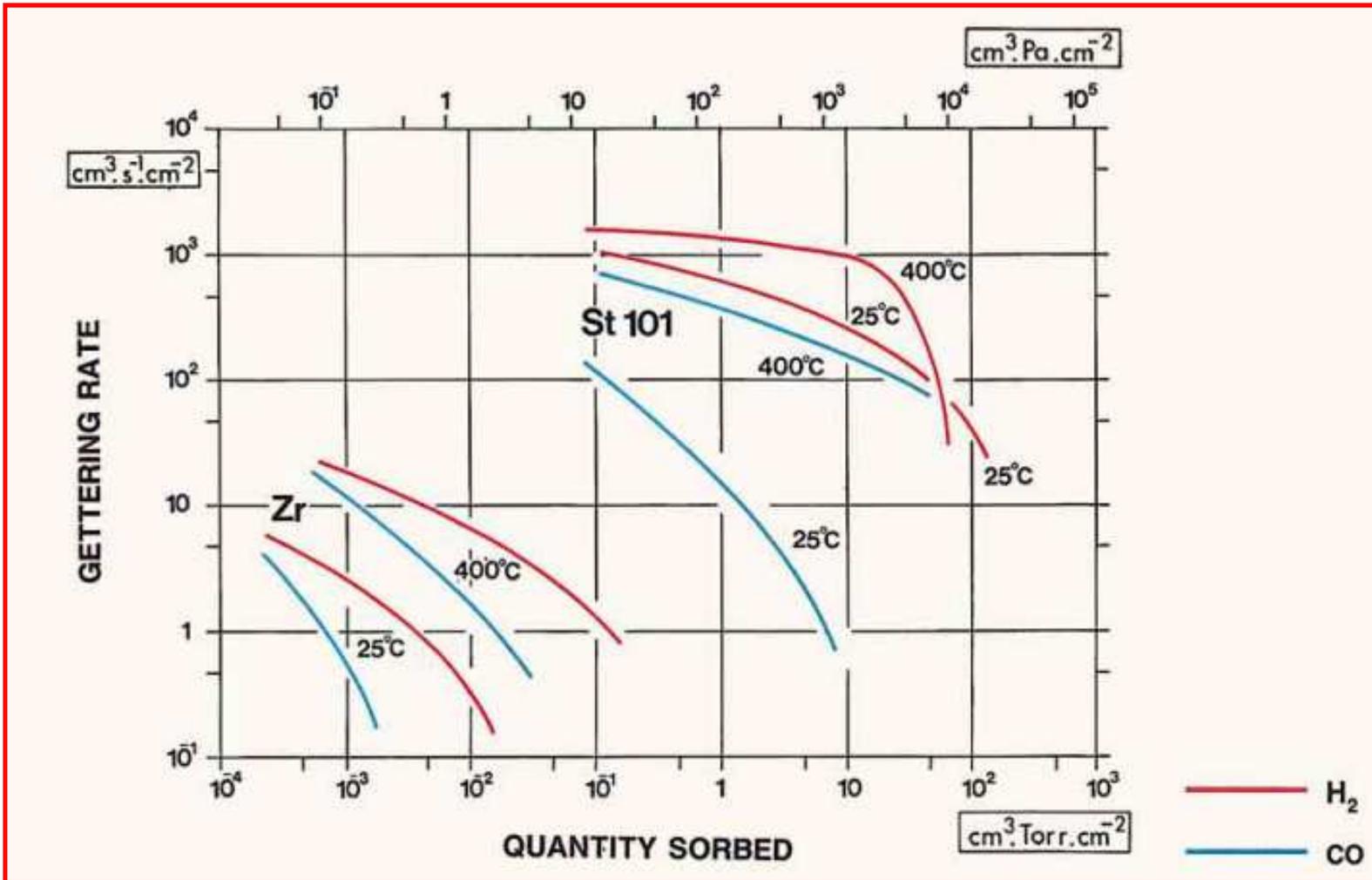
- Metal alloy made up of 84% Zr, 16% Al.
- First Zirconium based getter alloy introduced and still widely used today after 30 years.
- The operating temperature range of ST101 is 0 to 450° C.
- ST101 chemisorbs CO, CO₂, H₂O, N₂, and O₂ at high rates.
- ST101 activates at temperatures from 550 to 900° C.



ST 101 Alloy Activation Efficiency

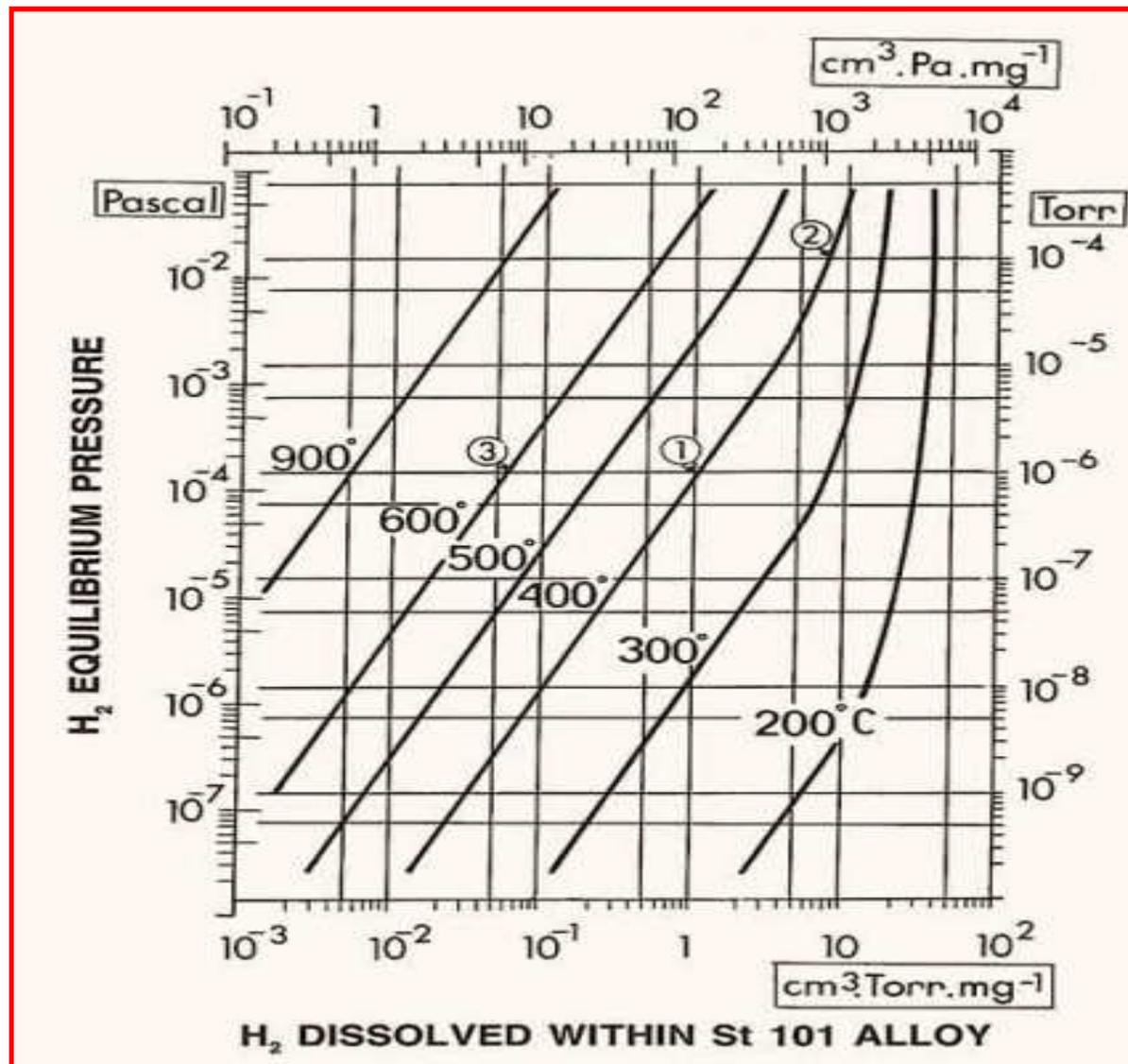
Ref. SAES Getters

SAES ST101[®] NEG – Pumping

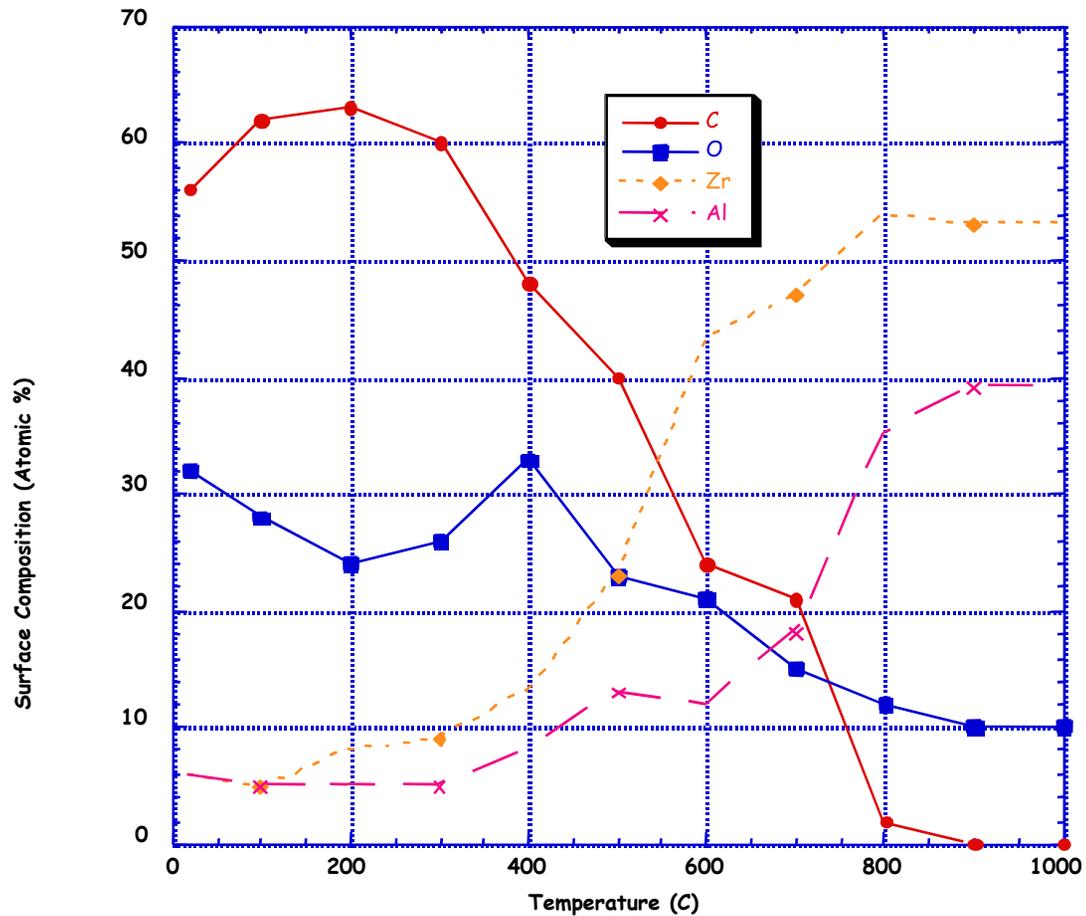


Ref. SAES Getters

SAES ST101[®] NEG – Hydrogen Solubility



ST101 Surface Composition vs. Temperature



Ref. SAES Getters

SAES ST707® Non-evaporable Getter



- ❖ Metal alloy made up of 70% Zr, 24.6% Va, and 5.4% Fe.
- ❖ The operating temperature range of ST707 is 20 to 100°C.
- ❖ ST707 chemisorbs CO, CO₂, H₂O, N₂, and O₂ at high rates.
- ❖ ST707 has much lower activation temperature.

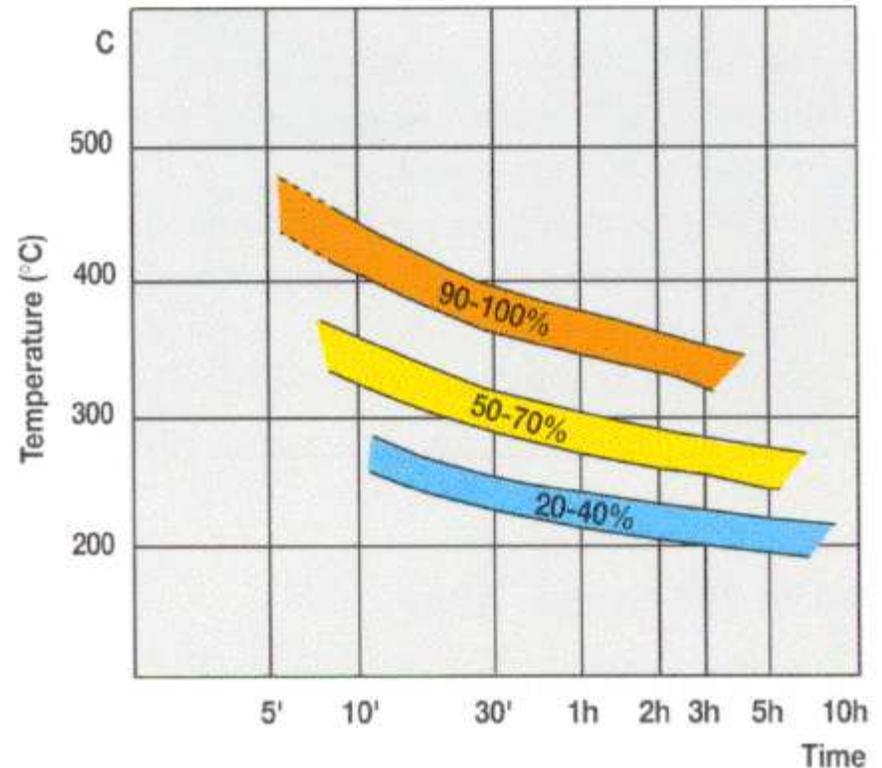
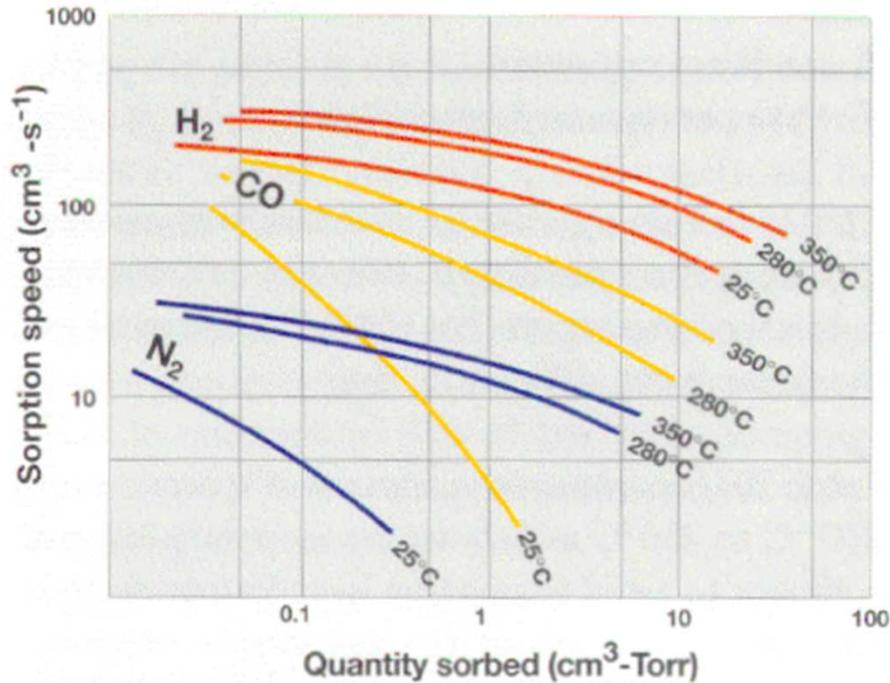
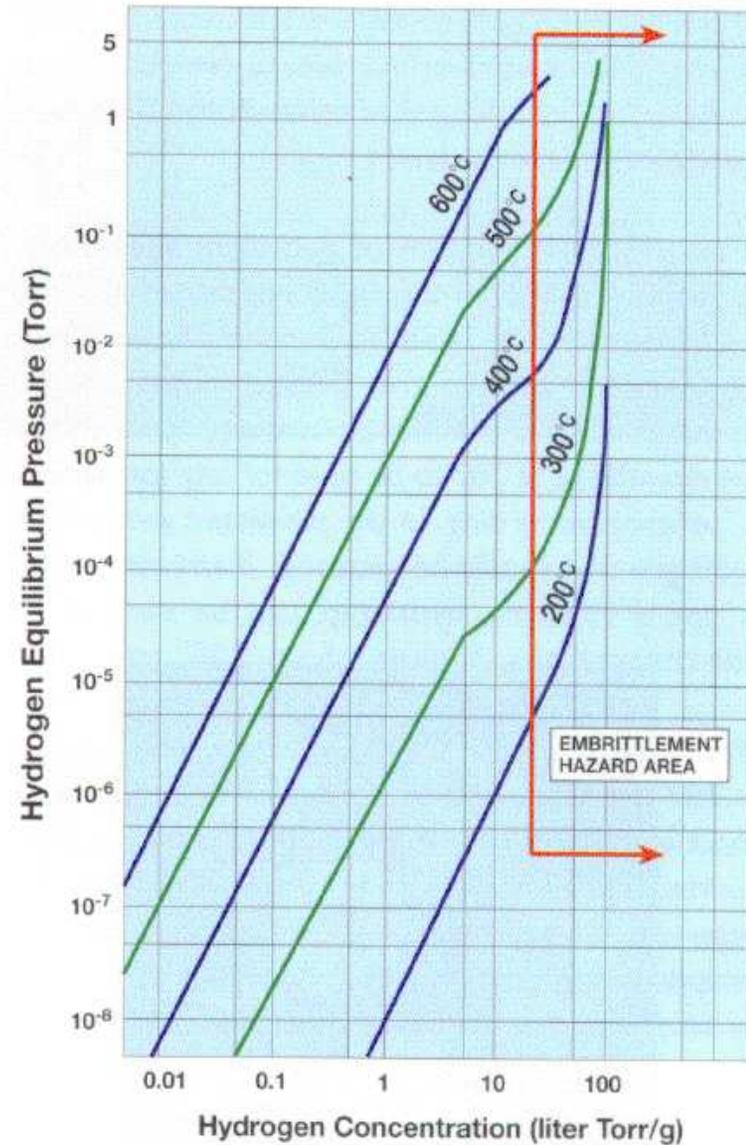


Fig. 1. Activation conditions and gettering efficiency of St 707

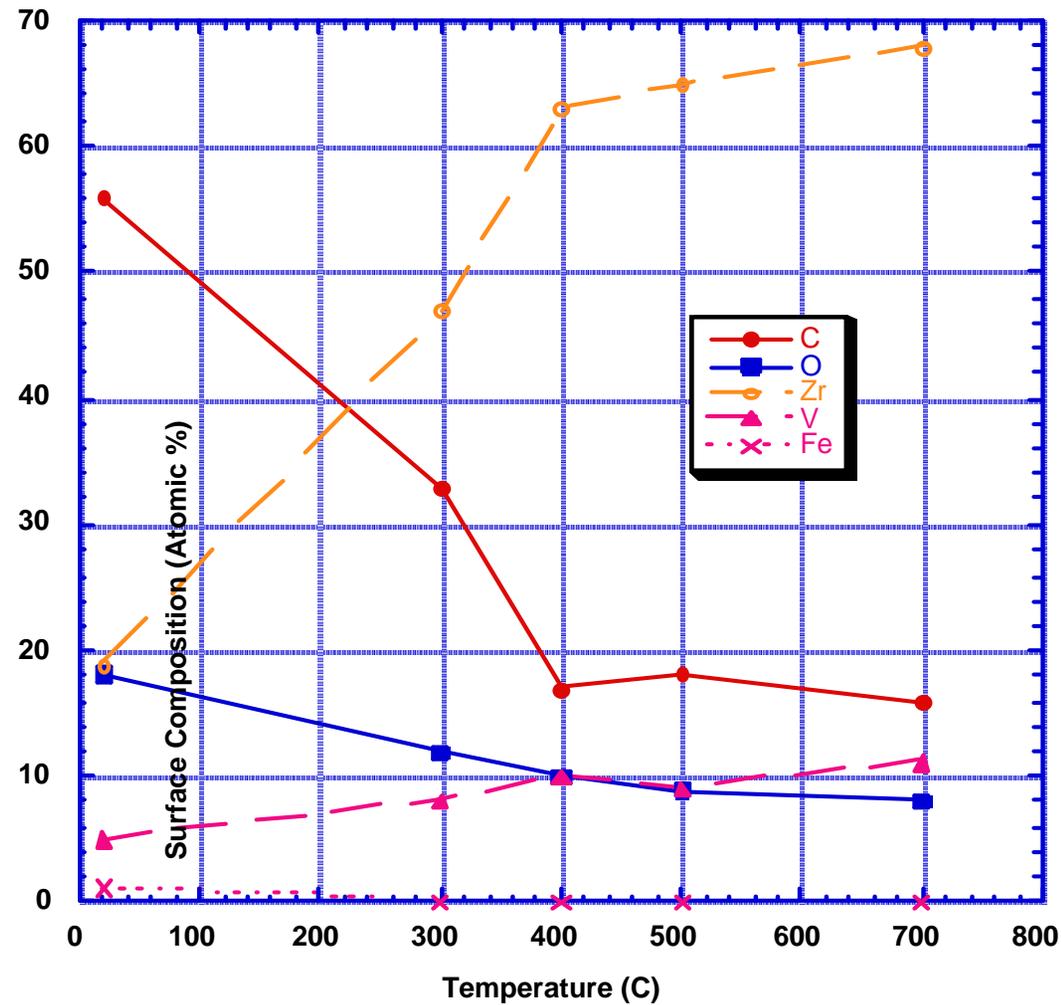
SAES ST707® NEG Pumping Performance



St 707 powder alloy: 100mg
 Geometric surface: 50 mm²
 Activation: 450°C for 10 min.
 Sorption: At the indicated temperatures



ST707 Surface Composition vs. Temperature





Other SAES NEG Alloys

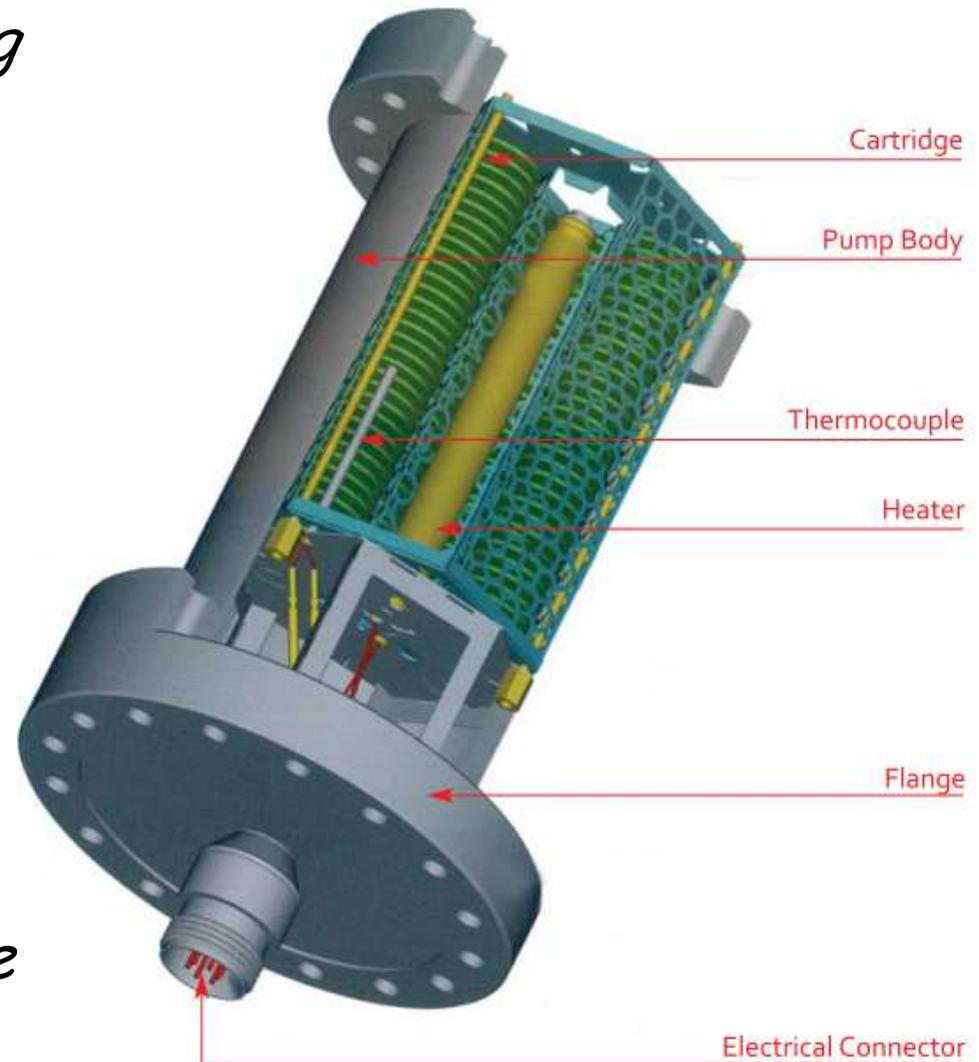
- ❑ *ST 172 - Zr, V, and Fe alloy.*
- ❑ *ST175 - Ti and Mo powder mixture, sintered form.*
- ❑ *ST185 - Ti-V alloy (obsolete !)*



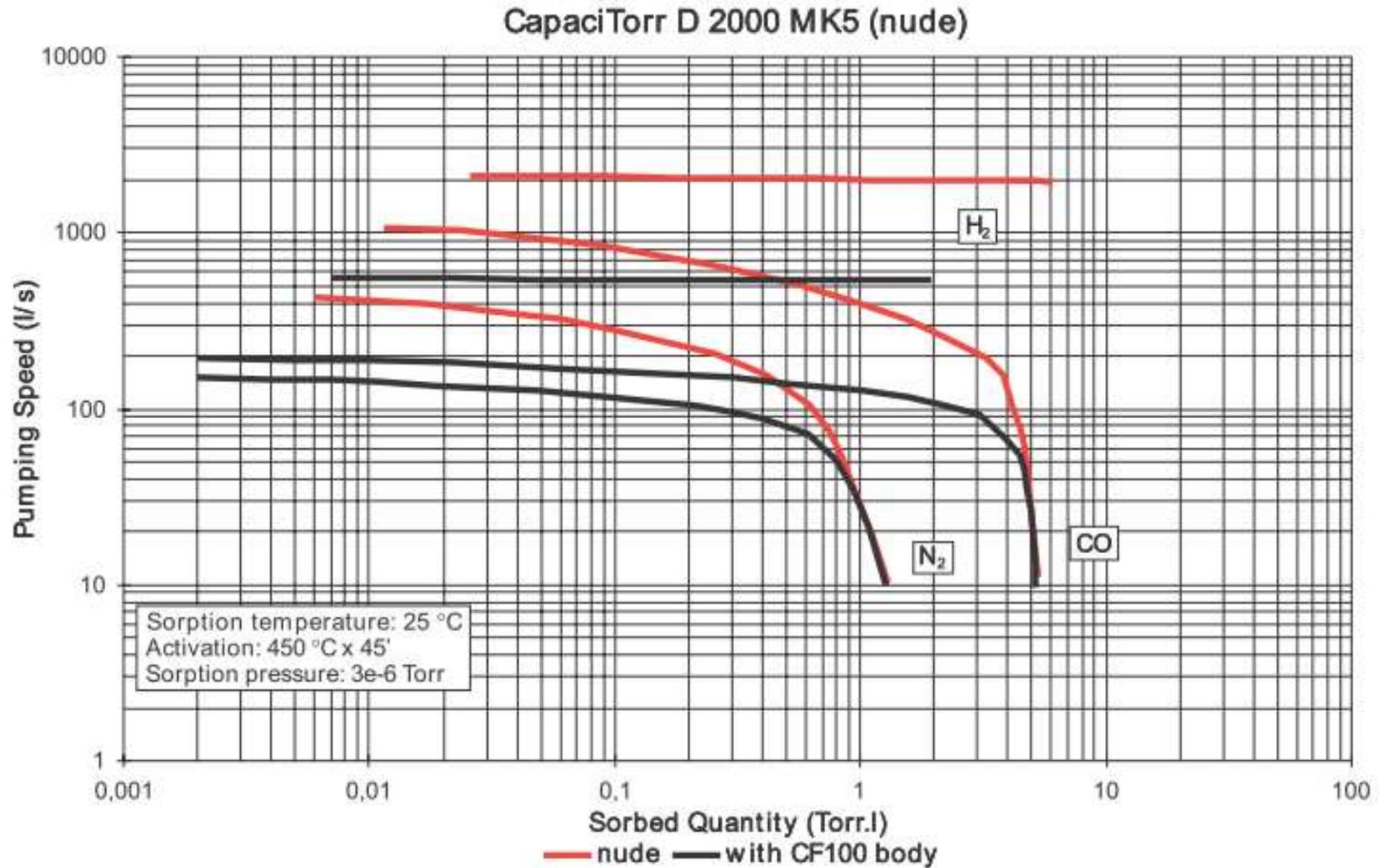
NEG Cartridge Pump Module – CapaciTorr®



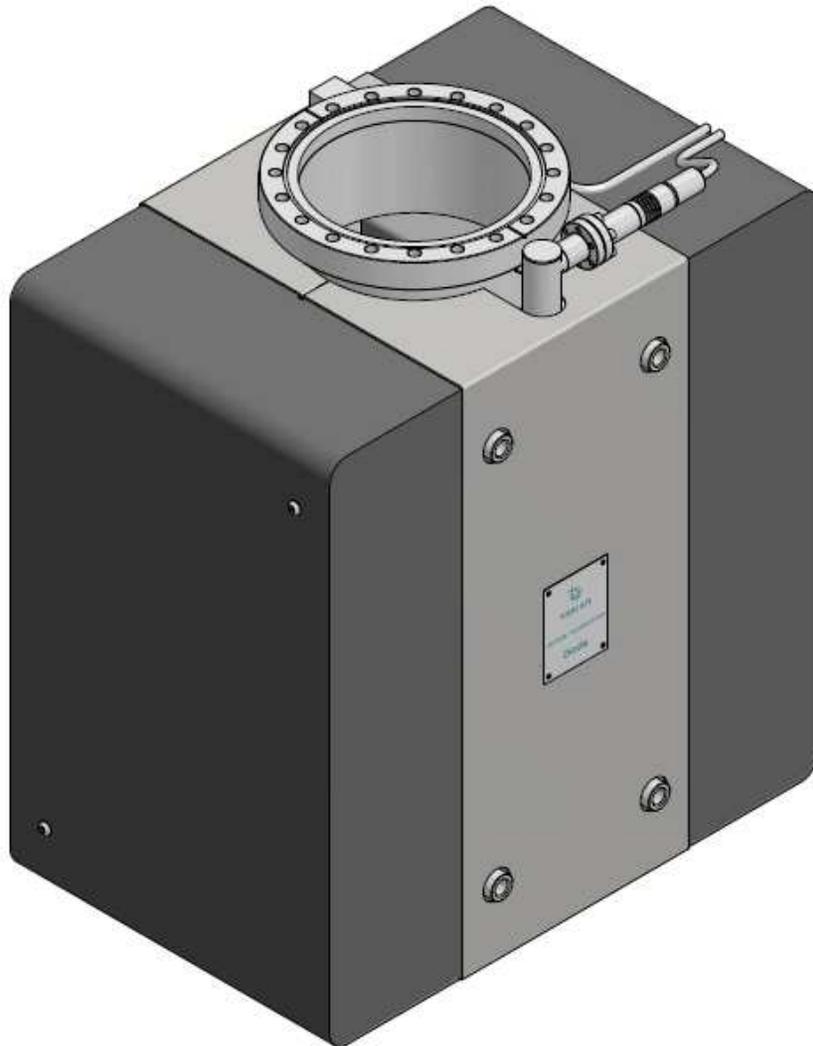
- ❑ *Complete compact pumping system, with matching controller for easy activation*
- ❑ *NEG materials: st172 blades/disks*
- ❑ *Pump sizes from 50 l/s to 2000 l/s, for H₂*
- ❑ *For large sizes, the NEG cartridges are replaceable*



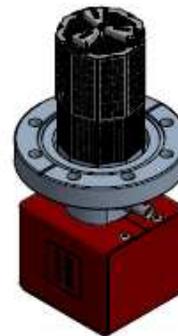
CapaciTorr® Pumping Performance



NEG – Ion Pump Combination – NexTorr®

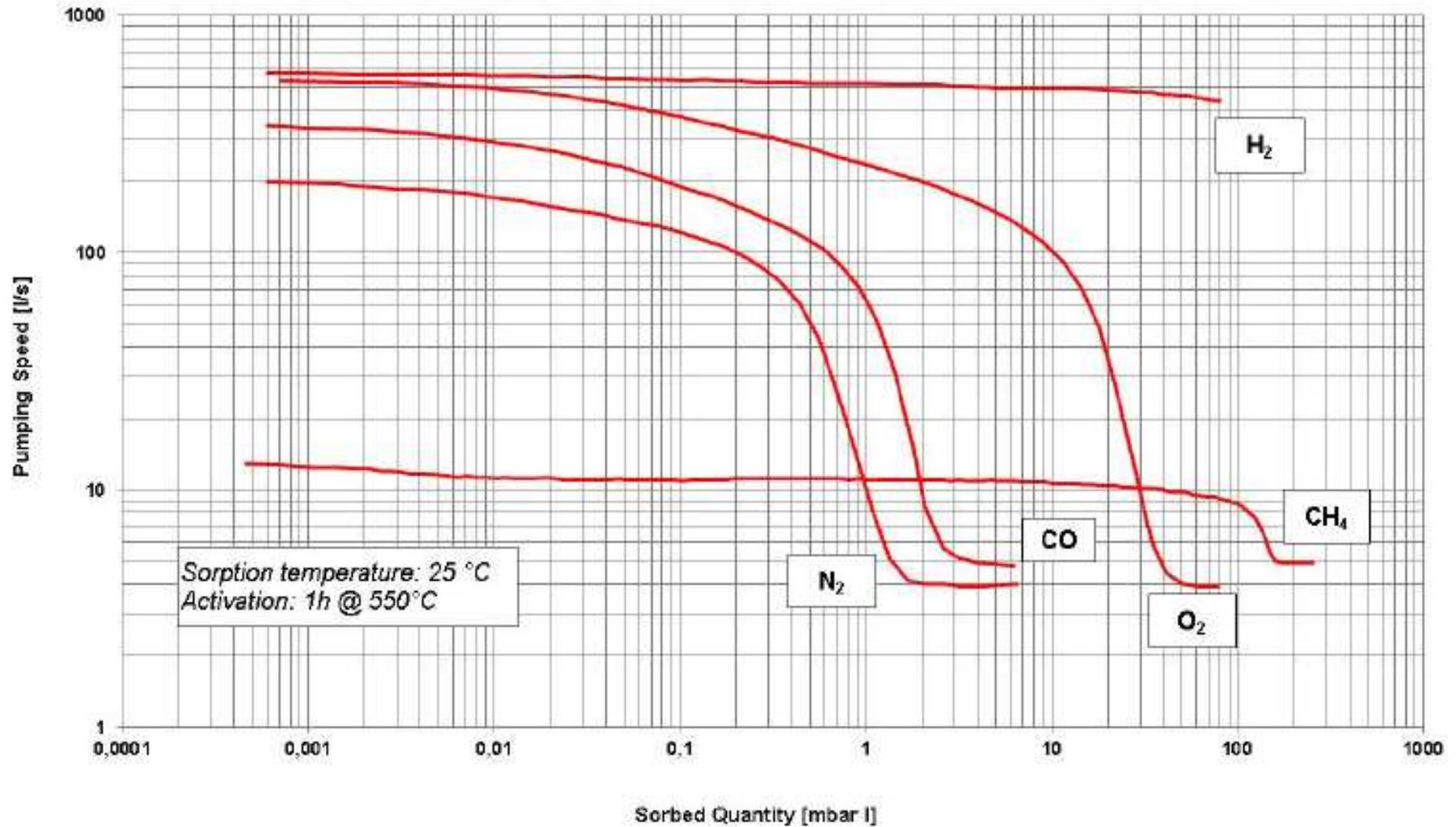


500 I/s VacIon Plus



NexTorr D500-5

Pumping Performance – NexTorr®

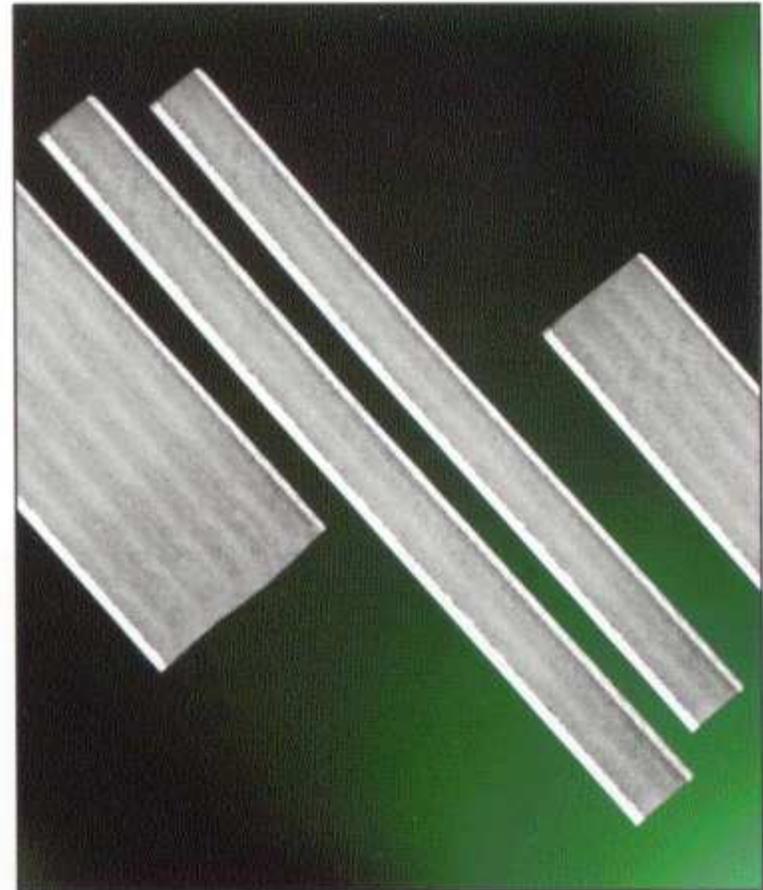


Main Technical Parameters – NexTorr® D500-5

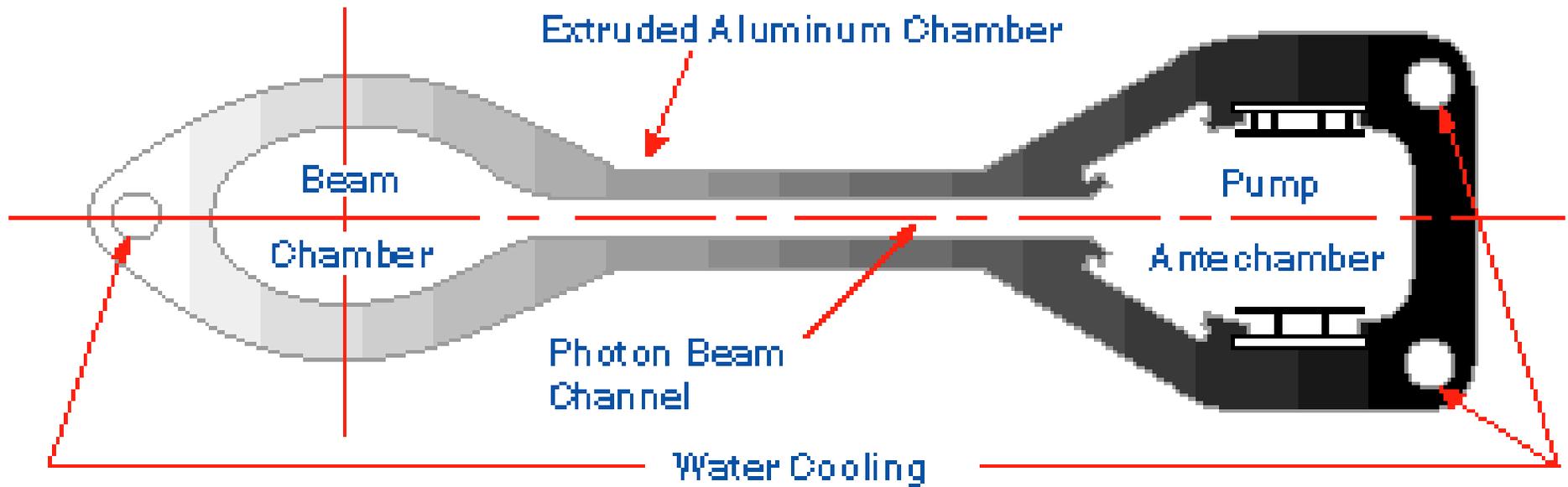


Initial pumping speed (l/s)	Gas	NEG activated	NEG saturated
	O ₂	500	4
	H ₂	500	6
	CO	340	5
	N ₂	200	4
	CH ₄	13	5
	Argon ¹	6	6
Sorption capacity (Torr·l)	Gas	Single run capacity ²	Total capacity ³
	O ₂	17	>1500
	H ₂	670	N/A ⁴
	CO	1.4	>360
	N ₂	0.8	>75
	CH ₄	137	50,000 hours at 10 ⁻⁶ Torr
NEG section	Getter alloy type		St 172
	Alloy composition		ZrVFe
	Getter mass (g)		68 g
	Getter surface (cm ²)		570
ION section	Voltage applied		DC +5kV
	Number of Penning cells		4
	Standard bake-out temperature		150°C

Other NEGs forms – Build your own pumps



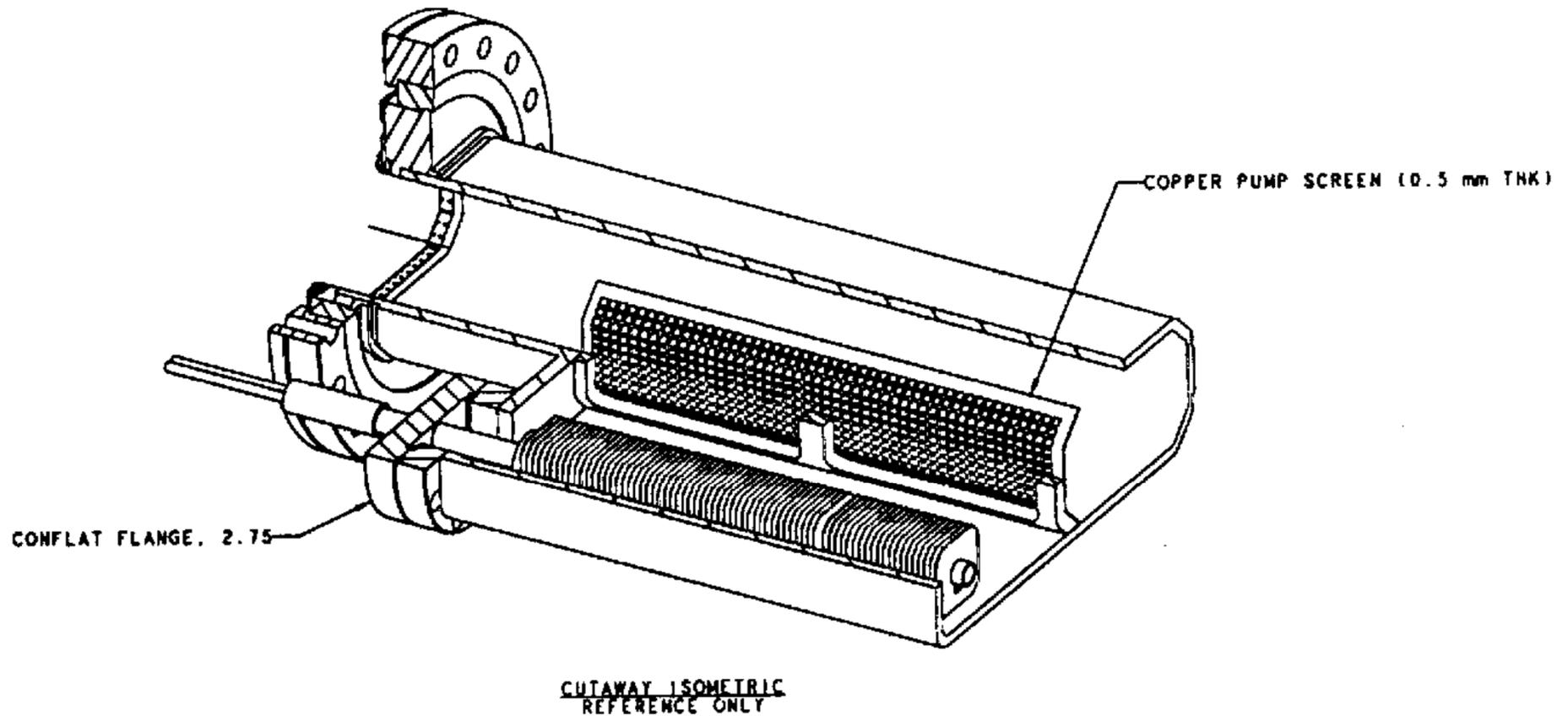
Distributed Pumping with NEG strips



APS Beampipe with NEG strips



LLNL NEG Pump in a PEP-II Vacuum Chamber



Combination Pumping Ion Pumps with TSP or NEG



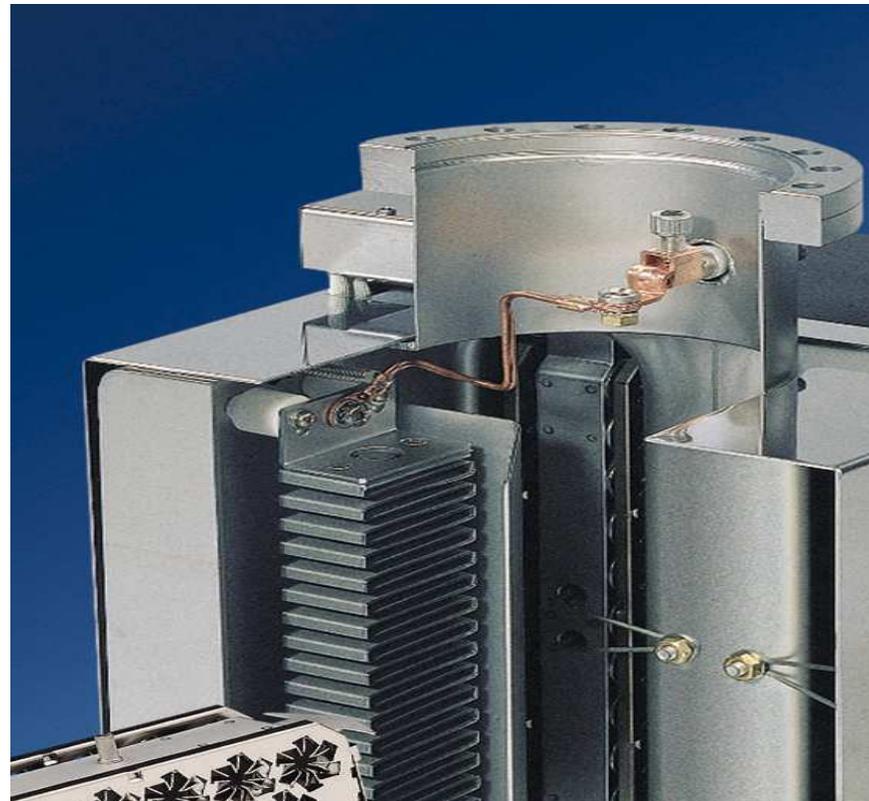
- Combination pumping produces greater pumping speeds for all gases.
 - TSP and NEG provide high pumping speeds for **getterable gases**.
 - Ion Pumps provide pumping of **argon** and **light hydrocarbons** (usually Noble Diode pumps are chosen).
- Combination pumping can be attained by:
 - Commercial combination pumps
 - Custom built combination pumps
 - Use of multiple types of pumps
- NEGs are used on systems where high constant pump speeds are required or on systems requiring distributed pumping.
- TSPs are used on systems with sudden large gas bursts, localized gas sources and/or frequent venting takes place.



Commercial Combination Pumps . . . Ion Pumps with TSP or NEG



Ion Pump with TSP filaments



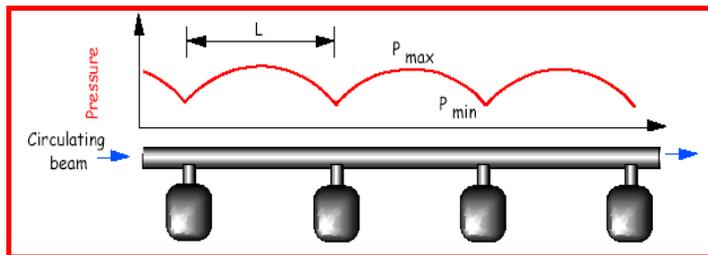
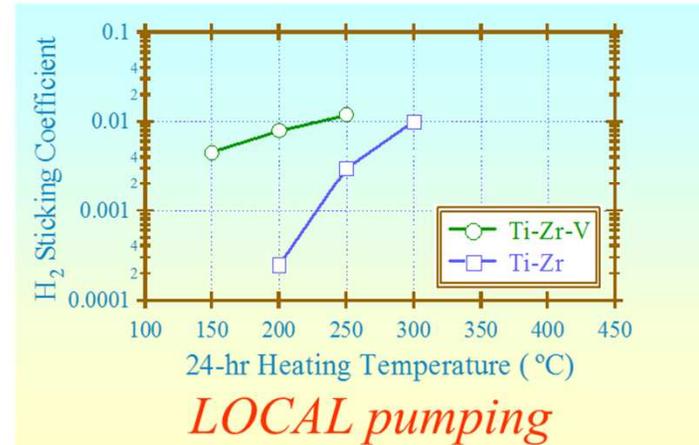
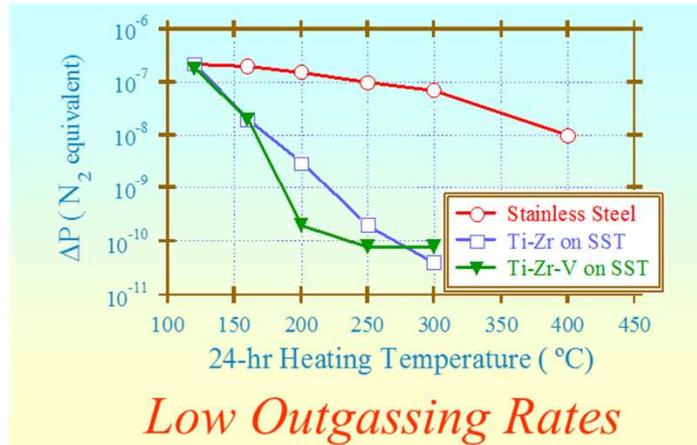
Ion Pump with NEG cartridge



NEG Thin Film for Accelerators



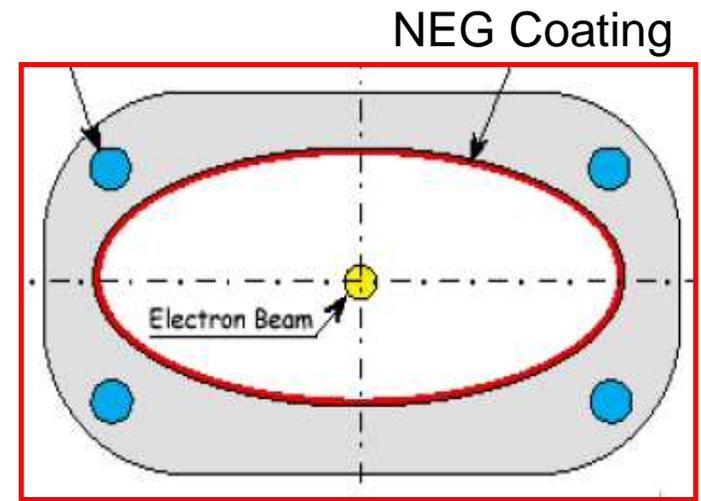
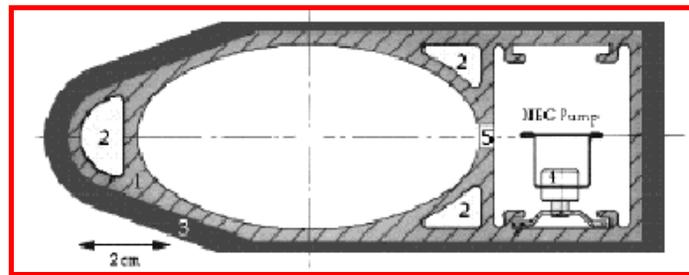
- Developed at CERN, by *Bevenuti, et al*



Integrated Pumping

Discrete Pumping

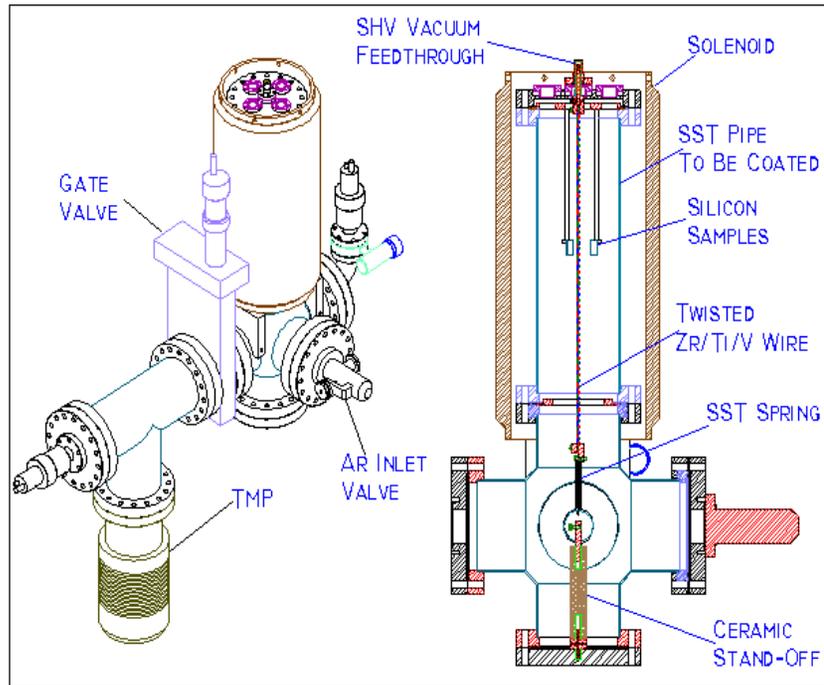
Distributed Pumping



Deposition of NEG Thin Films



Typical Sputtering Arrangement – A CLASSE Setup



- Cathode – Twisted wires
- Electric field (ion energy)
~ 600 V
- Magnetic field :
200 ~ 500 Gauss
- Sputtering gas : Ar or Kr
P = 2 ~ 20 mtorr

- DC or Magnetron Sputtering arrangement is commonly used.
- Coating surface cleanness is essential for good adhesion
- Sputtering gas purity extremely important



NEG Thin Film Characteristics



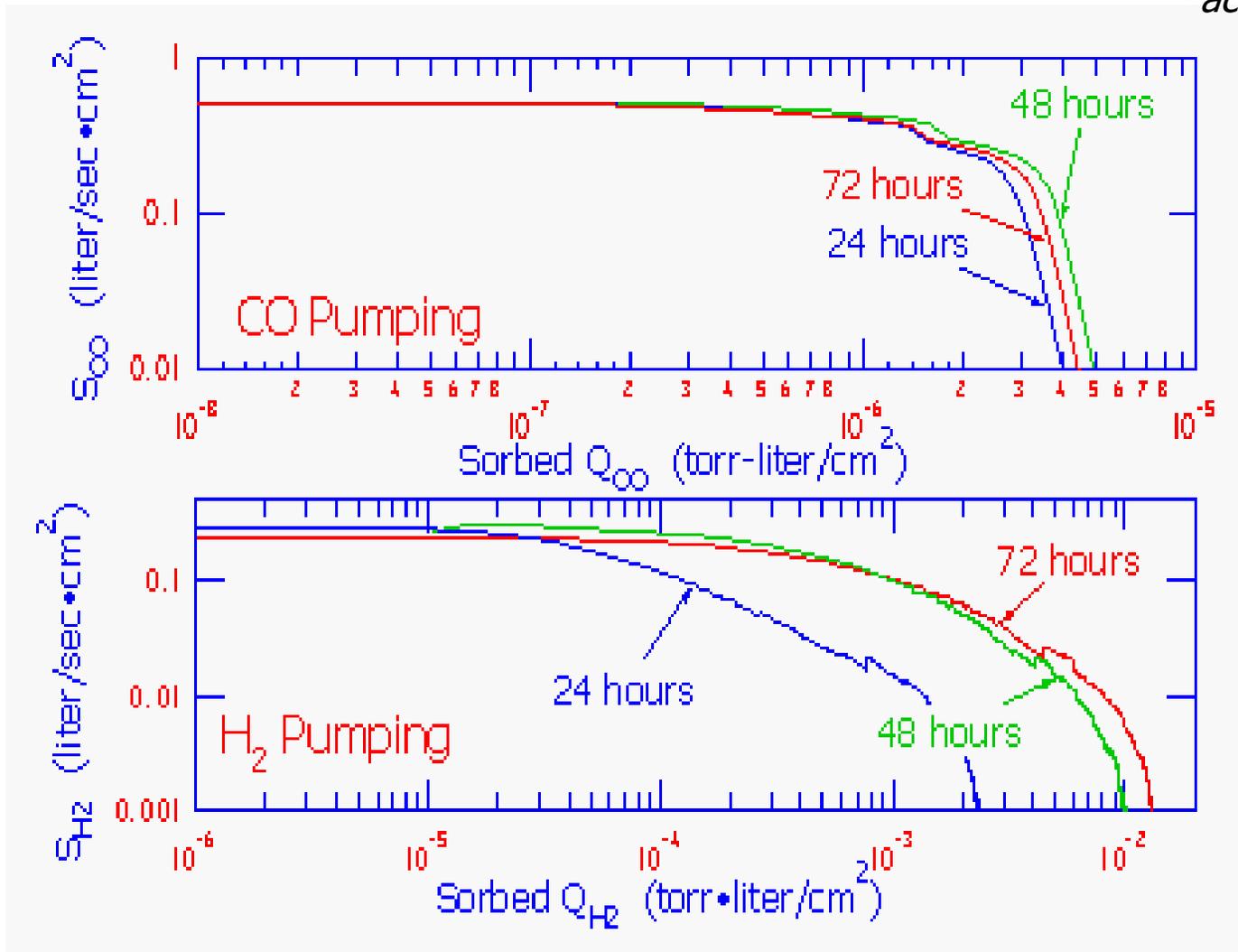
- ❑ *Most commonly deposited NEG thin films have elementary composition of $Zr_xV_yTi_z$, with x, y, z , close to unity.*
- ❑ *Stoichiometric balanced thin film tend to have lower activation temperature, probably due to smaller grain sizes.*
- ❑ *Pumping can be achieved at activation temperature as low as 150°C , though typical $\sim 250^\circ\text{C}$. Thus an in-situ bakeout can activate the NEG coating.*
- ❑ *Typical NEG thin film thickness: $2\sim 4\ \mu\text{m}$.*



NEG Coating Pumping Performance (1)



$T_{act} = 350^{\circ}\text{C}$

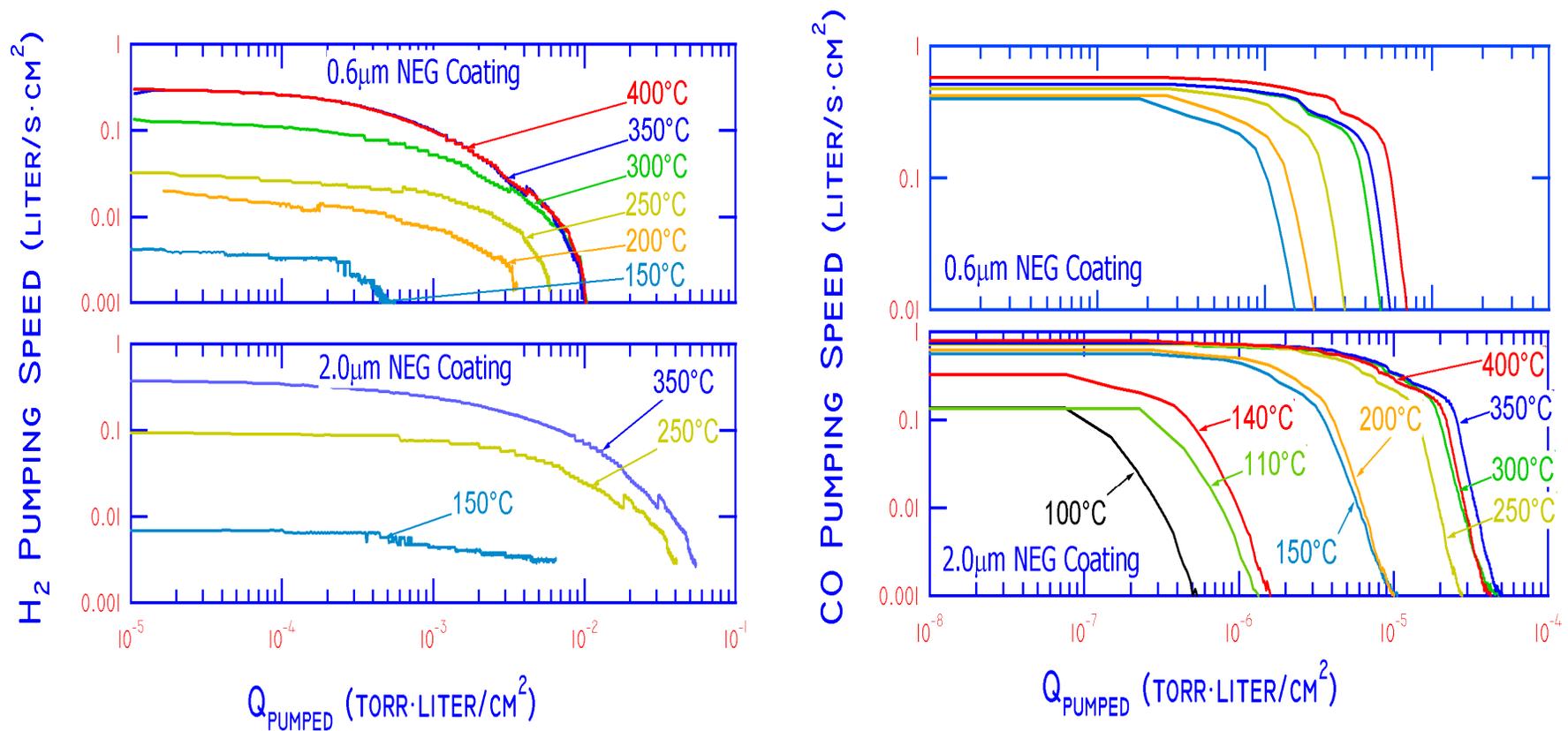


NEG Coating Pumping Performance (2)



Pumping Speed vs. Gas-load

Activation Temperature Dependence (48-hr activation)



NEG Film Total Capacity & Aging Effects



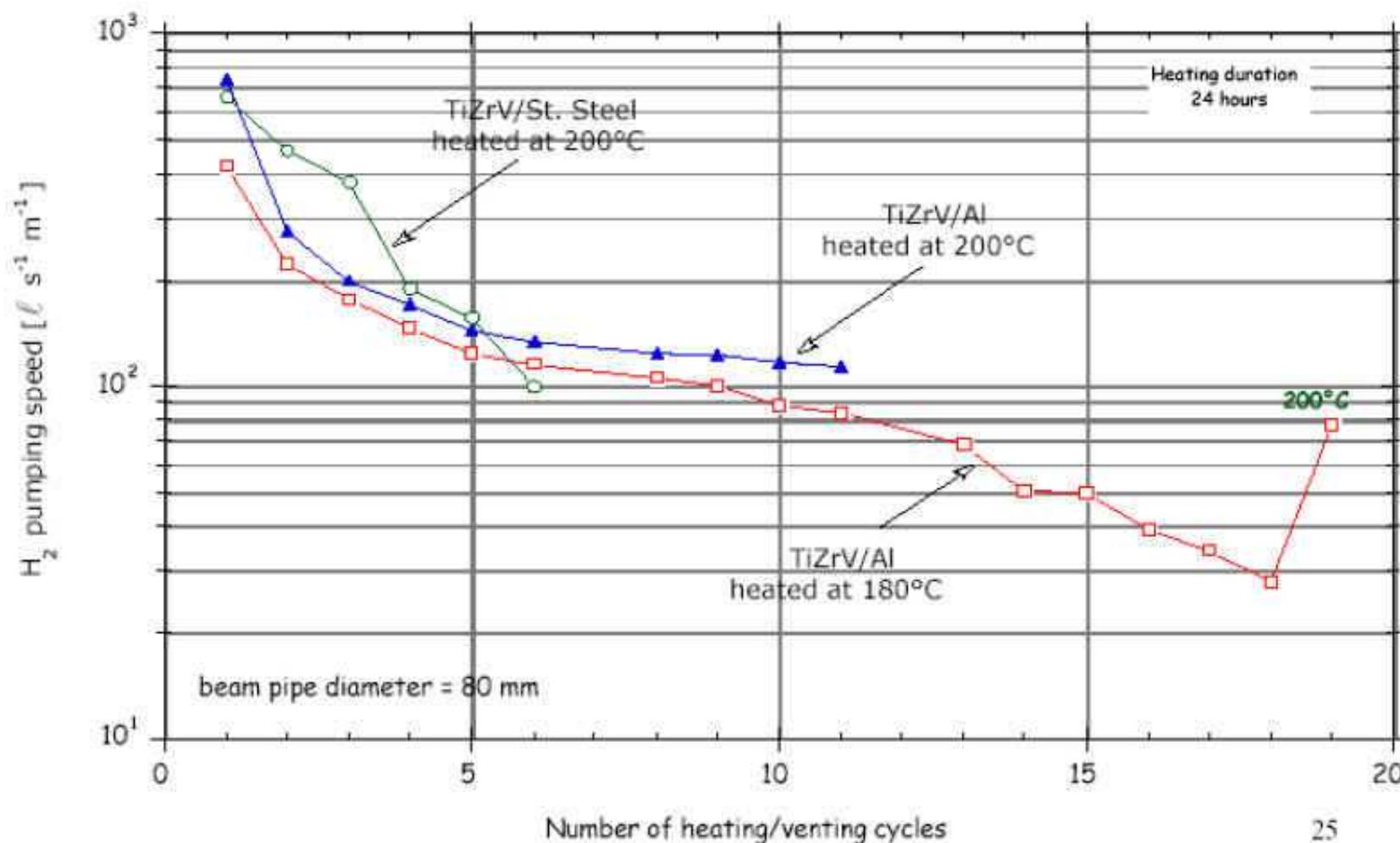
- Total pumping capacity of a NEG thin film depends on the film's solubility to oxygen, carbon, nitrogen, etc., and the film thickness

Using solubility of 5%, 1-nm saturated surface oxide layer
Estimated saturation/venting cycles for 1 μm NEG film > **50**

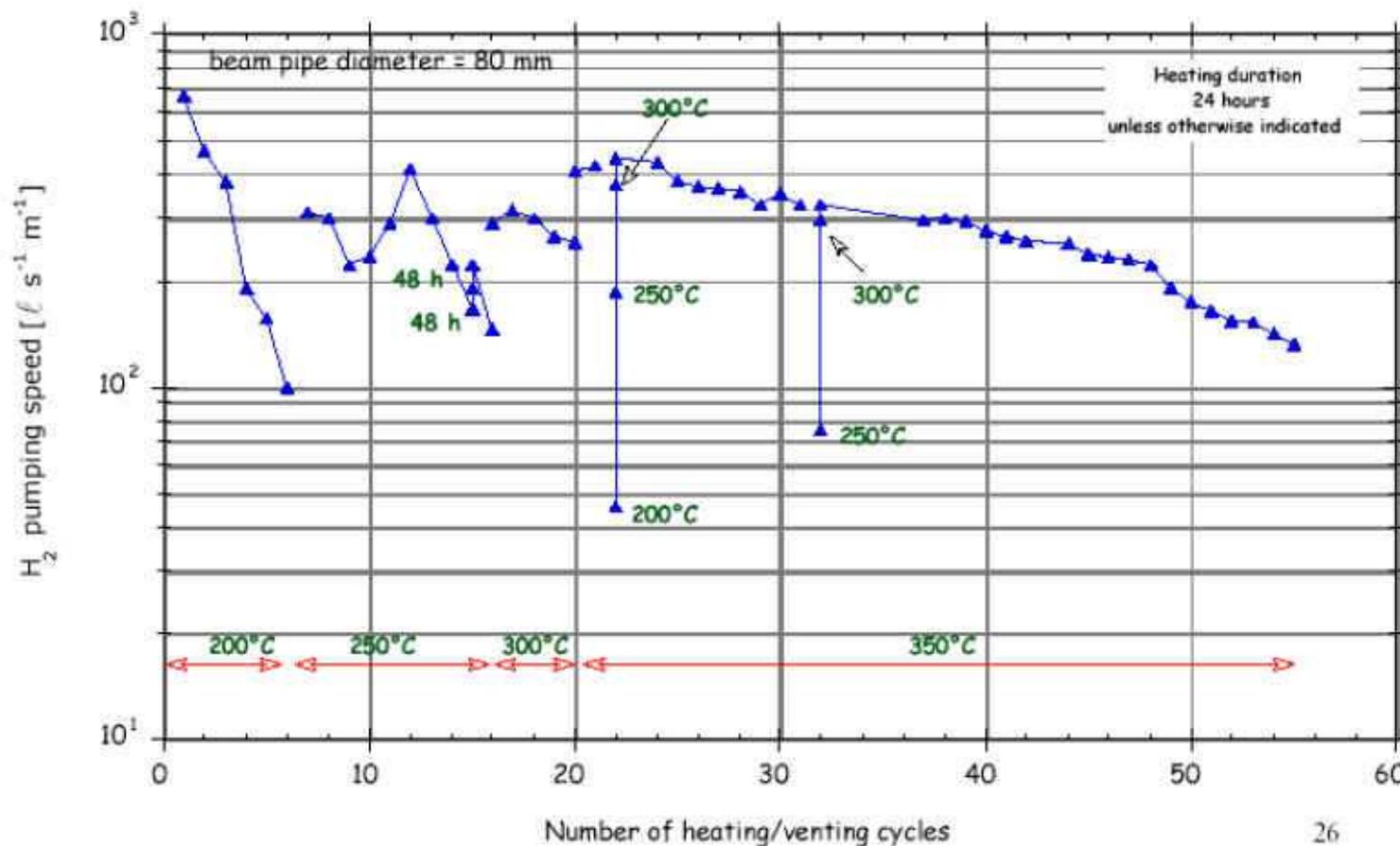
- Gradual aging is a deterioration of the thin film performance due to accumulation of oxygen in the film
 - Reduction of pumping speed and capacity
 - Increase of activation temperature



NEG Film Aging Effect



NEG Film Aging – More



Successful Applications of NEG Coatings



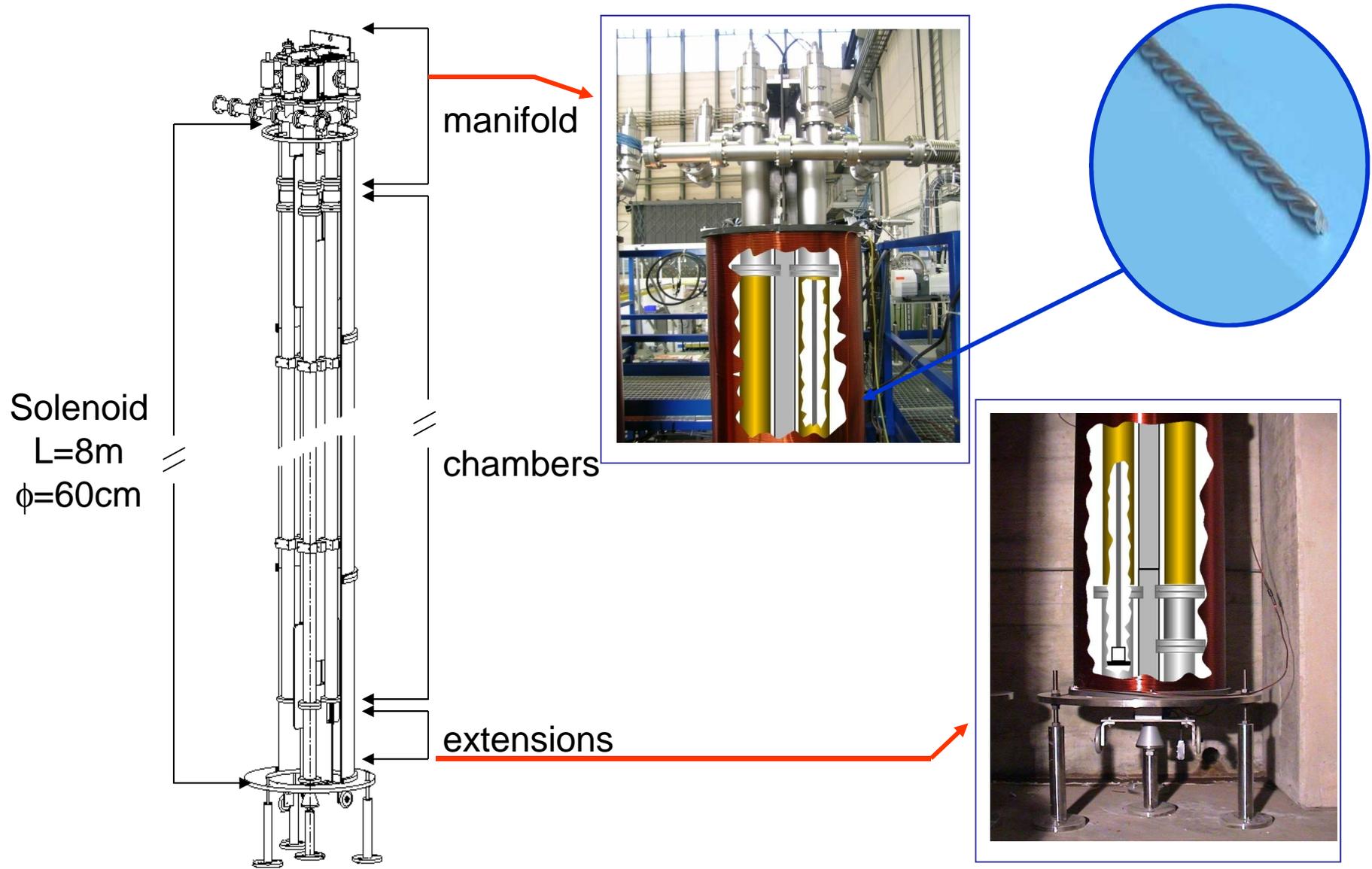
- NEG coating is an idea solution for long narrow-gapped undulator vacuum chambers
- All LHC warm beampipes were NEG coated.
- *ESRF* has had a very successful experience with the NEG-coated undulator chambers.
- Other new 3rd generation SR light sources, such as *SOLEIL* and *DIAMOND*, also used the NEG coatings for the undulator chambers.
- A *NEG Coating Workshop* was held at *DIAMOND* site, on 23/24 September 2002.



CERN's NEG Coating Facility



CERN's NEG Coating Facility – Details



CERN's NEG Coating Production



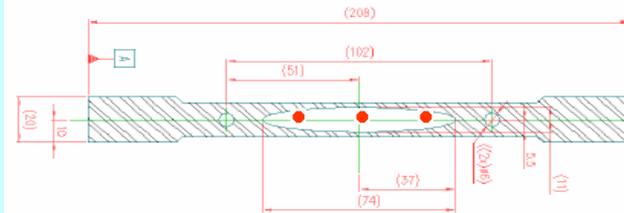
More than 1300 chambers coated with TiZrV NEG for the LHC.
Standard chambers are 7 m long, 80 mm diameter.



ESRF's NEG Coating Facility



A New NEG Coating Building @ESRF



Extruded Al-Chamber
5-m long, 11-mm Gap

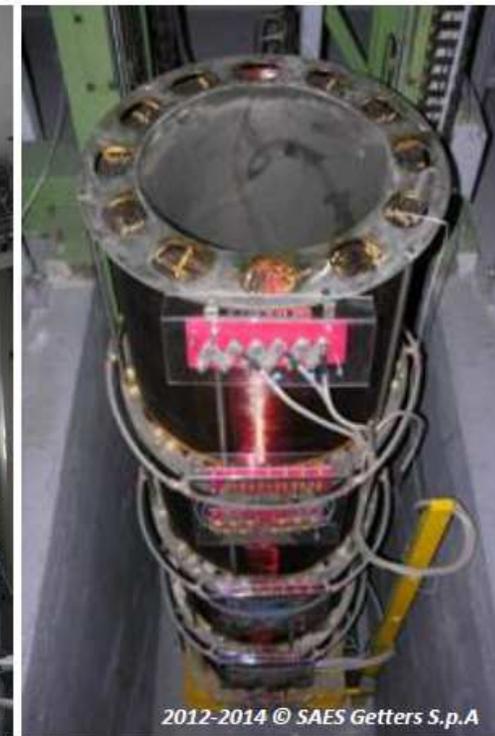
Motorized Air-cool
Solenoid (500 G @ 100Amp)



IntegraTorr® – SAES Getters' NEG Coating



- ❑ SAES Getters is licensed by CERN to provide commercial NEG coating services.
- ❑ All components to be coated by SAES are cleaned by CERN facility, to ensure good thin film adhesiveness.
- ❑ Known projects used this services: RHIC, CesrTA, etc.



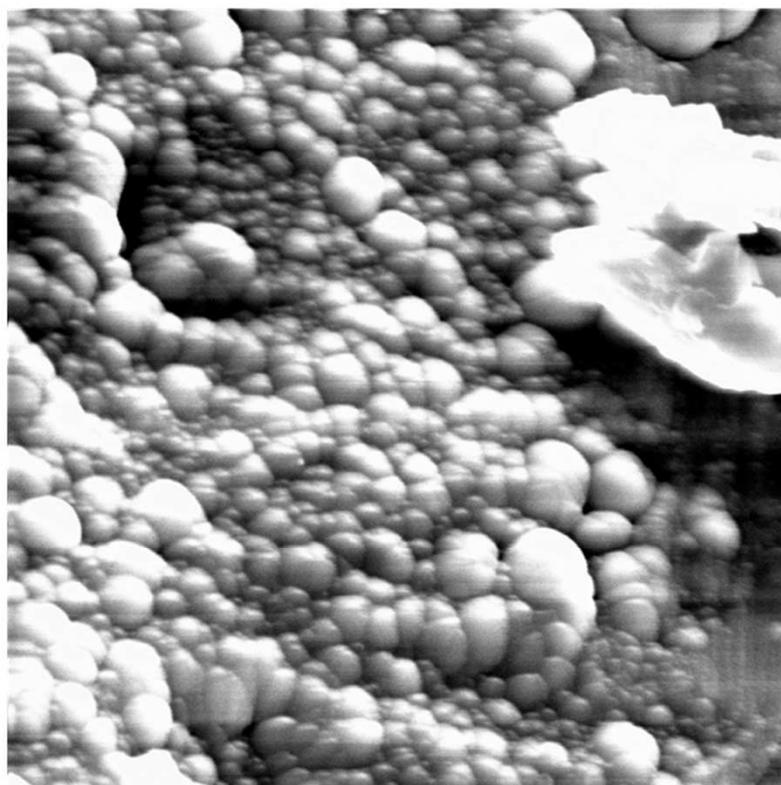
Word of Caution

Powder substance were found on the orifice disk, as well as on the coated surface, after extensive pumping tests

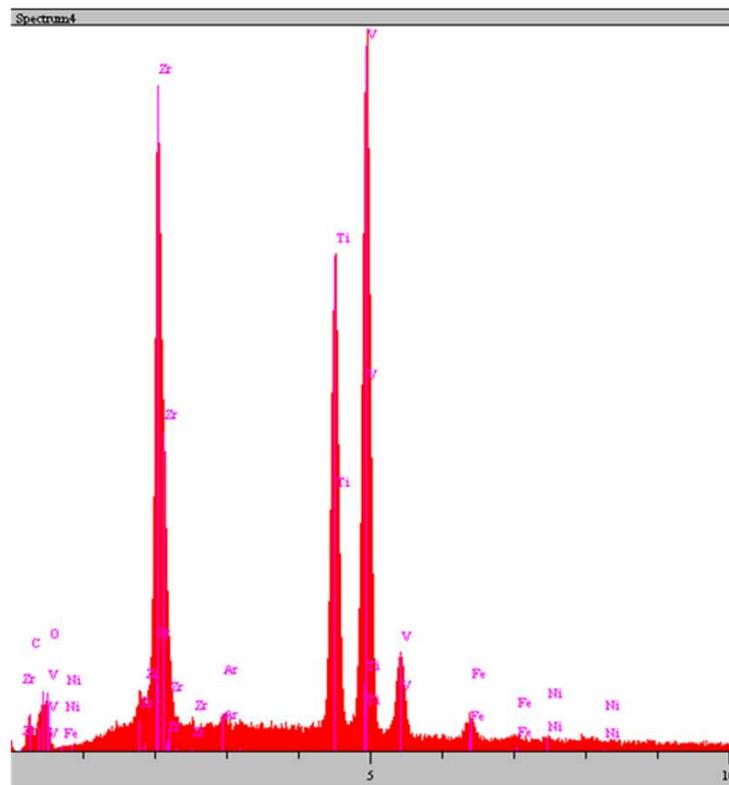


- The original coating had excellent bonding, by visual inspection and/or via 'tape testing'*
- Believe the coating was damaged by excessive H_2 sorption. More investigation planned*

Powder Confirmed to Be NEG



Powder SEM Image



Powder EDX Spectrum

NEGs or TiSPs



- *Both TiSPs and NEGs are great in deal with hydrogen gas load, the main gas in an UHV system*
- *If space available, TiSPs are the first choice*
 - *Much less cost*
 - *More operational friendly*
 - *'Un-limited' capacity*
- *Some practical questions regarding NEGs*
 - *How to reduce hydrogen from NEGs ?*
 - *Should the NEGs be thoroughly de-hydrogen before installation ? Or is that possible ?*
 - *What's sources of hydrogen in the commercial NEG modules/cartridges (in the NEG materials, or in the heating elements) ?*
 - *What's the best way to passivate NEGs for air exposure ?*

